

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner

Serial No.

: 10/628,817

Filed Inventors : July 28, 2003 : Hideki Ozawa : Fumio Aoki

Title

: ANTISTATIC FILM AND

: PROCESSES FOR ITS MANUFACTURE

Docket No.: 1259-03

Customer No.: 035811

Confirmation No.:

Dated: October 14, 2003

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

We submit herewith the usual Form PTO-1449 together with copies of publications listed therein. They are submitted to comply with the Applicants' duty of disclosure under 37 C.F.R. §1.56 and are believed related to this application.

We are submitting this in the spirit of voluntary disclosure and look forward with interest to the Examiner's action at an early date on the merits of the case.

It is accordingly requested that the Information Disclosure Statement be officially entered in the file of this case and that appropriate notification be made that it was considered in the prosecution of the case.

Respectfully submitted,

T. Daniel Christenbury Reg. No. 31,750

Attorney for Applicants

TDC:ks (215) 656-3381

FormPTCT449U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE				ATTY. DOCKET NO. 1259-03		SERIAL NO. 10/628,817		
OCT 1 6 2003	,, ,		APPLICANT Hideki Ozawa et al.					
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EXAMINER INITIAL*		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	IF APPROP	
	AA	5,180,627	1/19/93	Inoue et al.			12/2/91	
	AB	6,129,982	10/10/00	Yamaguchi et al.			4/6/98	
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	AL	2001-110819	4/20/01	JР				Abstract only
	AM	2000-053930	2/22/00	JР				Abstract only
		2001-115251	4/24/01	JР				Abstract only
	AN	10-077406	3/24/98	JP				Abstract only
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Sir:

Certificate of Mailing Under 37 CFR 1.8

For

Postcard Information Disclosure Statement Form PTO-1449 w/copies of publications

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date appearing below.

> Name of Applicant, Assignee, Applicant's Attorney or Registered Representative:

> > Piper Rudnick LLP Customer No. 035811

By:	(d)				
Date: 14 Oc	1 2003				